

Form PTO 1449 (Modified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		DOCKET NO.	SERIAL NO.
			005212/TCG/SPC/SB	NEW PATENT APPLICATION
			APPLICANT	SHREYAS KHER, ET AL.
			FILING DATE	GROUP ART UNIT
		HEREWITH	UNASSIGNED	

11040 U.S. Pro
09/90322



LIST OF REFERENCES CITED BY APPLICANT
(Use Several Sheets if Necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
WJ	AA	6,051,286	4/18/00	ZHAO ET AL.	—	—	
	AB	6,082,714	7/4/00	DORNFEST ET AL.	—	—	
	AC	6,077,562	6/20/00	DORNFEST ET AL.	—	—	
WA	AD	6,070,551	6/6/00	LI ET AL.	—	—	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
	AL				
	AM				
	AN				
	AO				
	AP				

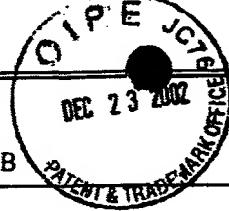
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	
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EXAMINER Wes MowDATE CONSIDERED 8/26/03

*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	DOCKET NO. 005212/TCG/SPC/SB	SERIAL NO. 09/903,222
		APPLICANT		
		SHREYAS KHER, ET AL.		
LIST OF REFERENCES CITED BY APPLICANT (Use Several Sheets if Necessary)		FILING DATE JULY 10, 2001	GROUP ART UNIT 1762	



U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLAS S	SUB CLASS	FILING DATE IF APPROPRIATE
WA	AA	5,674,563	10/07/97	TARUI ET AL.	—	—	
WA	AB	5,972,430	10/26/99	DIMEO, JR. ET AL.	—	—	
WA	AC	6,162,501	12/19/00	KIM	—	—	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
WA	AL	WO 01/99166	06/08/01	PCT	
WA	AM	JP 60 017078	01/28/85	JAPAN (ABSTRACT ONLY)	
	AN				

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

WA	AO	Cho, et al., "Improvement of Dielectric Properties of (Ba, Sr) TiO ₃ Thin Films Deposited by Pulse Injection Chemical Vapor Deposition", Applied Physics Letters, American Institute of Physics., Vol. 72, No. 7, pages 786-788 (1998).
WA	AP	Tanimoto et al., "Synchronously Excited Discrete Chemical Vapor Deposition of Ta ₂ O ₅ ", Journal of the Electrochemical Society, Vol. 141, No. 5, pages 1339-1346 (1994).
	AQ	
	AR	

EXAMINER <u>Wes Ward</u>	DATE CONSIDERED <u>4/26/03</u>
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